

## WEST Search History





DATE: Wednesday, May 09, 2007

| Hide?                    | <u>Set</u><br><u>Name</u> | <u>Query</u>  | <u>Hit</u><br><u>Count</u> |
|--------------------------|---------------------------|---|----------------------------|
|                          |                           | <i>DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=ADJ</i>  |                            |
| <input type="checkbox"/> | L15                       | L14 not l10   | 60                         |
| <input type="checkbox"/> | L14                       | L13 and l5  | 97                         |
| <input type="checkbox"/> | L13                       | L8 same (substrate or base or support or wafer)   | 13870                      |
| <input type="checkbox"/> | L12                       | L11 not l10   | 29                         |
| <input type="checkbox"/> | L11                       | L9 and l5   | 66                         |
| <input type="checkbox"/> | L10                       | L9 and l1   | 37                         |
| <input type="checkbox"/> | L9                        | L8 with (substrate or base or support or wafer)   | 9434                       |
| <input type="checkbox"/> | L8                        | (electrode or anode or cathode) with electrolyte with (layer or layer\$3 or coat or coating or film or deposit or deposit\$4) | 53741                      |
| <input type="checkbox"/> | L7                        | L6 not l2   | 141                        |
| <input type="checkbox"/> | L6                        | L5 same (layer or layer\$3 or coat or coating or film or deposit or deposit\$4)   | 217                        |
| <input type="checkbox"/> | L5                        | fuel cell same (MEMS or micro-electro-mechanical system or microelectro mechanical system)                                    | 500                        |
| <input type="checkbox"/> | L4                        | L3 not l2   | 49                         |
| <input type="checkbox"/> | L3                        | L1 same (layer or layer\$3 or coat or coating or film or deposit or deposit\$4)   | 125                        |
| <input type="checkbox"/> | L2                        | L1 with (layer or layer\$3 or coat or coating or film or deposit or deposit\$4)   | 76                         |
| <input type="checkbox"/> | L1                        | fuel cell with (MEMS or micro-electro-mechanical system or microelectro mechanical system)                                    | 292                        |

END OF SEARCH HISTORY

## Refine Search

### Search Results -

| Term   | Documents |
|--|-----------|
| (14 NOT 10).PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD.    | 60        |
| (L14 NOT L10 ).PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD. | 60        |

Database:

US Pre-Grant Publication Full-Text Database  
 US Patents Full-Text Database  
 US OCR Full-Text Database  
 EPO Abstracts Database  
 JPO Abstracts Database  
 Derwent World Patents Index  
 IBM Technical Disclosure Bulletins

Search:

L15

Refine Search

Recall Text

Clear

Interrupt

### Search History

DATE: Wednesday, May 09, 2007   [Purge Queries](#)   [Printable Copy](#)   [Create Case](#)

| <u>Set</u><br><u>Name</u>                                      | <u>Query</u>   | <u>Hit</u><br><u>Count</u> | <u>Set</u><br><u>Name</u><br>result set |
|--|--|----------------------------|---|
| <i>DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=ADJ</i> |  |                            |   |
| <u>L15</u>   | L14 not l10  | 60                         | <u>L15</u>                              |
| <u>L14</u>   | L13 and l5   | 97                         | <u>L14</u>                              |
| <u>L13</u>   | L8 same (substrate or base or support or wafer)  | 13870                      | <u>L13</u>                              |
| <u>L12</u>   | L11 not l10  | 29                         | <u>L12</u>                              |
| <u>L11</u>   | L9 and l5  | 66                         | <u>L11</u>                              |
| <u>L10</u>   | L9 and l1  | 37                         | <u>L10</u>                              |
| <u>L9</u>  | L8 with (substrate or base or support or wafer)  | 9434                       | <u>L9</u>                               |
| <u>L8</u>  | (electrode or anode or cathode) with electrolyte with (layer or layer\$3 or coat or coating or film or deposit or deposit\$4)                              | 53741                      | <u>L8</u>                               |
| <u>L7</u>  | L6 not l2  | 141                        | <u>L7</u>                               |
| <u>L6</u>  | L5 same (layer or layer\$3 or coat or coating or film or deposit or deposit\$4)<br>fuel cell same (MEMS or micro-electro-mechanical system or microelectro | 217                        | <u>L6</u>                               |

|           |  |     |           |
|-----------|--|-----|-----------|
| <u>L5</u> | mechanical system)   | 500 | <u>L5</u> |
| <u>L4</u> | L3 not l2  | 49  | <u>L4</u> |
| <u>L3</u> | L1 same (layer or layer\$3 or coat or coating or film or deposit or deposit\$4)            | 125 | <u>L3</u> |
| <u>L2</u> | L1 with (layer or layer\$3 or coat or coating or film or deposit or deposit\$4)            | 76  | <u>L2</u> |
| <u>L1</u> | fuel cell with (MEMS or micro-electro-mechanical system or microelectro mechanical system) | 292 | <u>L1</u> |

END OF SEARCH HISTORY